



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: : Date: 9/3/04
Schneider, et al. :
Serial No: 10/701,233 : Group Art Unit: 3729
Filed: November 3, 2003 :
For: " Method for a Patterned Etch Using a Holographic : Examiner: unknown
Mask"

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.56 and §1.97.

The Examiner is requested to consider and make of record the references cited on the accompanying Form PTO-1449.

This Information Disclosure Statement should not be construed as a representation that a search has been made, nor should it be construed as an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b).

If any fees are required, please charge them to Deposit Account No. 22-0265. This form is submitted in duplicate.

Respectfully submitted,

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